



CERTIFICATE OF MAILING 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

April 29, 2005 Date

Signature

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

MATTHEW A. PURDY

Serial No.: 10/634,013

Filed: August 4, 2003

For: DYNAMIC METROLOGY SAMPLING

METHODS, AND SYSTEM FOR

PERFORMING SAME

Group Art Unit: 2125

Examiner: Unknown

Atty. Dkt. No.: 2000.108900/TT5512

Customer No.: 23720

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. Because the filing date of the present application is after June 30, 2003, copies of the listed U.S. patents are not included. Copies of the listed foreign patent document and journal article are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R §§ 1.97(g),(h), this Information Disclosure Statement is not

to be construed as a representation that a search has been made, and is not to be construed to be

an admission that the information cited is, or is considered to be, material to patentability as

defined in 37 C.F.R. § 1.56(b).

In accordance with 37 C.F.R § 1.97(e)(1), Applicant hereby certifies that each item of

information contained in this Information Disclosure Statement was cited in a communication

from a foreign patent office in a counterpart foreign application not more than three months prior

to the filing of the present statement, as evidenced by the date of the enclosed PCT Search

Report.

Applicant respectfully requests that the listed documents be made of record in the present

case.

Respectfully submitted,

WILLIAMS, MQRGAN & AMERSON

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Form PTO-1449 (modified List of Patents and Publications for INFORMATION DISCLOSURE STATEMENT

Atty. Docket No. Serial No. 2000.108900/TT5512 10/634,013

Applicant

Matthew A. Purdy

(Use several sheets if necessary)

Filing Date: August 4, 2003 Group: 2125

U.S. Patent Documents See Page 1

Foreign Patent Documents See Page 1

Other Art See Page 1

U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
	A1	5,541,846	7/30/96	Secrest	364	468.17	
	A2	6,442,496 B1	8/27/02	Pasadyn et al.	702	83	V 100
	A3						
	A4						
	A5	····					

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
	B1	WO 02/23289 A2	3/21/02	PCT	G05B	13/02	Yes
	B2		. , ,				
	В3						

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation				
	C1	Williams et al., "Optimized Sample Planning for Wafer Defect Inspection," IEEE, pp. 43-46, 1999				
	C2					
	C3					

T3	MINER:	
$\mathbf{H} \mathbf{V}$	MINED.	
11/1/1/1	AIVI II VI II. IX.	

DATE CONSIDERED:

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.